re Application of:

Moon, et al.

Serial No.: 10/025,144

Confirmation No.:

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Filed:

December 18, 2001

For:

Method and Apparatus for

Polishing Metal and **Dielectric Substrates**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813

Examiner:

Stephen W. Smoot

CERTIFICATE OF MAILING

37 CFR 1.8

hereby certify that this correspondence is being deposited on 10/2/, 2003 with the United States Postal Scales and , 2003 with the United States Postal Service as First Class Mall in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signature

SUBMISSION OF FORMAL DRAWINGS

Attached please find attached (6) sheets of formal drawings, with gummed labels on the back identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

comparison fee should be charged Deposit Account No. 0782/AMAT/5999/KMT. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at 713/623-4844.

Respectfully submitted,

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